

Docket No.

215891US2/sm

MAY 01 2002  
PATENT & TRADEMARK OFFICE  
JC117

#3  
5.7.2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Yoshinori TERUI, et al.

SERIAL NO: 09/985,737

GAU: 2879

FILED: November 6, 2001

EXAMINER:

FOR: ELECTRON GUN AND A METHOD FOR USING THE SAME

INFORMATION DISCLOSURE/RELATED CASE STATEMENT UNDER 37 CFR 1.97

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

The applicant(s) wish to make of record the references cited in the attached European Search Report listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.  
 A check is attached in the amount required under 37 CFR §1.17(p).

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RELATED CASES

Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.  
 A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

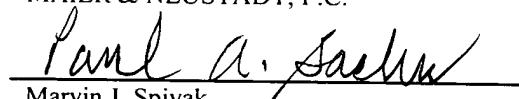
Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.  
 No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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SHEET 1 OF 1

Form PTO 1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO. 215891US2		SERIAL NO. 09/985,737		
LIST OF REFERENCES CITED BY APPLICANT			APPLICANT Yoshinori TERUI, et al.				
			FILING DATE November 6, 2001		GROUP 2879		
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
AA		4,430,570	02/07/84	Tadahiro TAKIGAWA, et al.			
AB		4,482,838	11/13/84	Masaji ISHII, et al.			
AC		5,837,165	11/17/98	Shigeki OTANI, et al.			
AD							
AE							
AF							
AG							
AH							
AI							
AJ							
AK							
AL							
AM							
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
AN					YES	NO	
AO							
AP							
AQ							
AR							
AS							
AT							
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AU	Ken HARADA, et al., Journal of Electron Microscopy, vol. 40, no. 1, pages 1-4, XP-000234583, "SINGLE-CRYSTAL LaB <sub>6</sub> AS THERMAL FIELD EMITTER OF HIGH BRIGHTNESS ELECTRON SOURCE", February 1, 1991					
	AV	Patent Abstracts of Japan, JP 58-040729, March 9, 1983					
	AW	Patent Abstracts of Japan, JP 09-129166, May 16, 1997					
	AX	Patent Abstracts of Japan, JP 08-184699, July 16, 1996					
	AY	Patent Abstracts of Japan, JP 56-035342, April 8, 1981					
Examiner				Date Considered			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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